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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Hideki Fukano

Serial No.: 10/005,705

Filed: December 4, 2001

For: SEMICONDUCTOR PHOTO-DETECTOR, SEMICONDUCTOR PHOTO-DETECTION DEVICE AND PRODUCTION METHODS THEREOF

Date: September 30, 2002

Group Art Unit: 2815

Examiner: J. Jackson

Assistant Commissioner for Patents
Washington, D.C. 20231

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OCT-9 2002

TECHNOLOGY CENTER 2800

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J. Steptoe
10-17-02

RESPONSE TO RESTRICTION REQUIREMENT

Sir:

This is in response to the Restriction Requirement dated August 30, 2002 in which restriction between the inventions of Group I and Group II was required.

Applicant elects the process invention of Group II, claims 4-8, 10 and 13-16 to a device without traverse.

Applicant reserves the right to file a divisional application directed to the subject matter covered in the non-elected claims 2, 3, 9, 11, 12.

A favorable action is respectfully requested.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on September 30, 2002

Respectfully submitted,

Samuel H. Weiner

Name of applicant, assignee or
Registered Representative

Signature

September 30, 2002

Date of Signature

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